Selective Oxidative Deprotection of Trimethylsilyl Ethers in Solution and under a Solvent Free Condition

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Direct oxidation of trimethylsilyl ethers to their corresponding carbonyl compounds has drawn considerable attention in recent years.¹⁻¹⁵ However, some of the reported methods suffer from disadvantages such as long reaction time,^{7,9} low yields of the products¹³ and tedious work-up procedure.⁸ Therefore, introduction of new methods for such functional group transformation is still in demand.

Recently, we have reported that $(NH_4)_2Cr_2O_7$ in the presence of Al(HSO₄)₃ and wet SiO₂ can be used as an efficient reagent for the oxidation of alcohols to their corresponding carbonyl compounds.¹⁶ In continuation of this study, we were interested in extending the applicability of this reagent system to the oxidation of the other functional groups. In this paper, we report a new, efficient and selective method for the oxidative deprotection of trimethylsilyl ethers to their corresponding carbonyl compounds using the above mentioned reagent system in solution and under a solvent free condition. Oxidative deprotection of different types of trimethylsilyl ethers was investigated in the absence of solvent with ammonium dichromate in the presence of Al(HSO₄)₃ and wet SiO₂ at room temperature (Scheme 1).

Yields and reaction times are given in Table 1. Benzylic trimethylsilyl ethers, including electron donating and withdrawing groups are converted to their corresponding carbonyl compounds in high yields (Table 1). Trimethylsilyl ethers containing alkyl ethereal groups are converted to their corresponding aldehydes and ketones without cleavage of carbon-oxygen bond (Table 1, entries 9, 10). This method is also very effective for the oxidation of non-benzylic trimethylsilyl ethers (Table 1, entries 13-16). Over-oxidation of the products was not observed by this method. In order to compare the results obtained under a solvent free condition with those obtained in solution, we studied the oxidation reaction in *n*-hexane. As shown in Table 1, in most cases, there are appreciable differences between the results obtained in solution and those under a solvent free condition. By omitting the solvent, the reaction time was reduced in

 $\begin{array}{c} A \text{ or } B \\ R_1R_2CHOSiMe_3 & \longrightarrow & R_1R_2CO \\ A: (NH_4)_2Cr_2O_7/ Al(HSO_4)_{3/} \text{ wet } SiO_2, \text{ solvent free, rt} \\ B: (NH_4)_2Cr_2O_7/ Al(HSO_4)_{3/} \text{ wet } SiO_2, n-hexane, \text{ rt} \end{array}$

addition to ease of the work-up procedure. It should be noted that the oxidation did not proceed using any of Al(HSO₄)₃, ammonium dichromate or wet SiO₂ alone, which presumably suggested the *in situ* generation of H₂CrO₄ in low concentration at the surface of wet SiO₂ by the solid inorganic acid salts Al(HSO₄)₃ and (NH₄)₂Cr₂O₇.

Tetrahydropyranyl ethers do not undergo oxidative deprotection by this method. Therefore, in order to show the selectivity of the described method, we have also performed competitive oxidative deprotection reactions. The experimental results show that trimethylsilyl ethers are oxidized selectively in the presence of tetrahydropyranyl ethers (Scheme 2). These selectivities are useful achievements in organic synthesis.

In conclusion, we have introduced a mild, efficient and selective method for the selective oxidative deprotection of trimethylsilyl ethers using ammonium dichromate in the presence of $Al(HSO_4)_3$ and wet SiO_2 in solution and under a solvent free condition.

Experimental Section

General: Trimethylsilyl and tetrahydropyranyl ethers and $Al(HSO_4)_3$ were prepared according to the literature procedures.^{17,18,19} All oxidation products are known compounds; they are identified by comparison of their physical data, IR and NMR spectra with those of authentic samples. Yields refer to isolated products or their 2,4-dinitorphenylhydrazones.

Oxidative deprotection of trimethylsilyl ethers under a solvent free condition. General procedure: The substrate (1 mmol) was added to a mixture of $(NH_4)_2Cr_2O_7$ (0.75 mmol, 0.189 g), Al(HSO₄)₃ (0.75 mmol, 0.237 g) and wet SiO₂ [(SiO₂/H₂O: 50% *wt.*), 0.1 g] The resultant mixture was stirred at room temperature for the specified time (Table 1). The progress of the reaction was monitored by GC or TLC. The reaction mixture was triturated with CH₂Cl₂ (10 mL) and then filtered. Anhydrous MgSO₄ was added to the filtrate and the mixture was filtered after 10 min. The filtrate was evaporated on a rotary evaporator and the resulting crude material was purified on a silica gel plate or silica gel column with appropriate eluents. Pure carbonyl compounds were obtained in 85-95% yields (Table 1).

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Table 1. Oxidative deprotection of trimethylsilyl ethers

Entry	Substrate	Product	Solvent free oxidation		Oxidation in solvent	
			Time (min)	Isolated Yield %	Time (min)	Isolated Yield %
1	CI	СНО	10	95	10	90
2	CI	CI	15	95	20	85
3	CI	CI	15	92	180	80
4	OTMS Br	CHO Br	15	90	50	85
5	NO ₂ OTMS	NO ₂ CHO	20	95	180	82
6	O ₂ NOTMS	O ₂ N, CHO	45	90	180	85
7	OTMS Me	CHO	10	90	35	85
8	OH	СНО	15	88	150	80
9	OTMS		15	90	180	85
10	OTMS	СНО	20	92	120	60
11	OTMS	↓	20	95	30	90
12		\mathbf{n}	20	90	35	80
13	ОТМЯ	СНО	10	85	40	82
14	CTMS	СНО	15	95	120	60
15	-OTMS	 o	40	90	130	80
16	OTMS	F	45	95	150	85



Scheme 2

Oxidation of trimethylsilyl ethers in *n***-hexane. General procedure:** In a round-bottomed flask (20 mL) equipped with a magnetic stirrer a suspension of $(NH_4)_2Cr_2O_7$ (0.75 mmol, 0.189 g), Al(HSO₄)₃ (0.75 mmol, 0.237 g) and wet SiO₂ [(SiO₂/H₂O: 50% *wt.*), 0.1 g)] in *n*-hexane (5 mL) was prepared. The substrate (1 mmol) was added to the mixture and stirred at room temperature for the specified time (Table 1). The progress of the reaction was monitored by GC or TLC. The mixture was filtered and the solid material was washed with CH₂Cl₂ (10 mL). The filtrate was evaporated on a rotary evaporator and the resulting crude material was purified on a silica gel plate or silica gel column with appropriate eluents. Pure carbonyl compounds were obtained in 60-90% yields (Table 1).

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Notes